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**Response under 37 C.F.R. § 1.116  
Expedited Procedure  
Examining Group 1765**

PATENT  
ATTORNEY DOCKET NO. 041501-5415

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Il Gweon KIM ) Confirmation No.: 7445  
Application No.: 09/987,738 ) Group Art Unit: 1765  
Filed: November 15, 2001 ) Examiner: B. Tran  
For: METHOD FOR FORMING SILICON )  
QUANTUM DOTS AND METHOD FOR )  
FABRICATING NONVOLATILE )  
MEMORY DEVICE USING THE SAME )

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, Mail Stop AF  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**AMENDMENT UNDER 37 C.F.R. § 1.116**

In response to the Final Office Action dated September 23, 2003 (Paper No. 6), the period for response to which extends through December 23, 2003, entry of the following amendments is respectfully requested to place the application in clear condition for allowance or, alternatively, in better form for appeal.

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DEC 01 2003  
TC 1700